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IN	THE	UNITED	STATES	<b>PATENT</b>	AND 7	[RAD]	EMARK	<b>OFFICE</b>

In re United States Patent Application of:

XU, Chongying, et al.

Application No.: 10/015,326

Date Filed:

Applicant:

**December 13, 2001** 

Title: METHOD FOR REMOVAL

> OF IMPURITIES IN CYCLIC SILOXANES USEFUL AS PRECURSORS FOR LOW DIELECTRIC CONSTANT

THIN FILMS

Docket No.:

ATMI-515 (7486)

Examiner:

Virginia MANOHARAN

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## FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Virginia MANOHARAN

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I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on February 28, 2005, to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Yongzhi Yang	
February 28, 2005	

Date

## APPOINTMENT OF ASSOCIATE ATTORNEY OF RECORD IN U.S. PATENT APPLICATION NO. 10/015,326

I, STEVEN J. HULTQUIST, as principal attorney of record in the above-identified patent application, hereby appoint as associate attorney of record in said application:

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2771-515 (7486)

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